

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	Kyoung-Ju SHIN et al.		
Assignee:	Samsung Electronics Co., Ltd.		
Title:	THIN FILM DIODE PANEL AND MANUFACTURING METHOD OF THE SAME		
Serial No.:	10/578,028	Filing Date:	April 27, 2006
Examiner:	Thanh Nhan P. NGUYEN	Group Art Unit:	2871
Docket No.:	PANK01883 US	Confirm No.:	9578

Cupertino, California
April 09, 2010

Filed Via EFS-Web

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the non-first Office Action dated Jan. 12, 2010, please amend the application as set forth below.

Amendment to Specification begins on page 2 of this paper.

Claims Listing begins on page 3 of this paper.

Remarks begin on page 7 of this paper.